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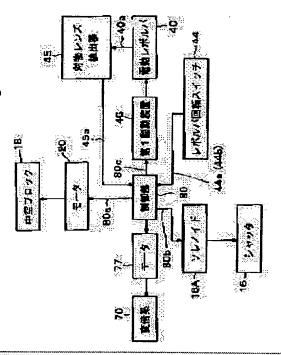
TAKEUCHI ATSUSHI

(54) MICROSCOPIC DEVICE

(57)Abstract:

PROBLEM TO BE SOLVED: To provide a microscopic device capable of easily observing a sample at higher magnification than an objective lens having the maximum magnification held by a revolver.

SOLUTION: This microscopic device is equipped with a motordriven revolver 40 holding plural objective lenses, an observation optical system observing an observed image obtained through the objective lens, a variable power system 70 arranged in the observation optical system and enlarging an observed image, an objective lens detector 45 detecting the objective lens arranged in the observation optical system and a revolver rotary switch ill switching the objective lens. In the device, a control part 80 arranges the system 70 in the observation optical system by referring to a detection signal 45a from the detector 45 when a rotating direction signals 44a and 44b for switching the objective lens to the maximum magnification are inputted from the switch 44.



LEGAL STATUS

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